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Seiko Seiki STP-iXA3306C

Technical Specifications

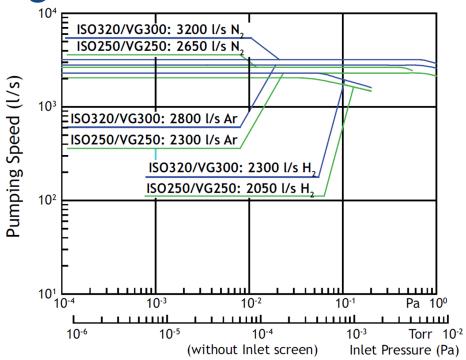
Inlet flange size	ISO250F/ VG250/ ICF305	ISO320F/ VG300/ ICF356	
Backing port size	KF40		
Pumping speed N ₂	2650	3200	Litres/second
Pumping speed Ar	2300	2800	Litres/second
Compression ratio N ₂ /H2	>10 ⁸ / 2 x 10 ³		
Ultimate pressure	10 ⁻⁷ (10 ⁻⁹)		Pa (Torr)
Allowable backing pressure	266 (2)		Pa (Torr)
Max gas flow N ₂ *1 (water cooled only)	4000 (6.76)		sccm (Pa m³/sec)
Max gas flow Ar *1 (water cooled only)	2100 (3.55)		sccm (Pa m³/sec)
Rated speed	27700		rpm
Starting time	<10		minutes
Mounting position	Any orientation		
Input voltage	200-240		V
Max input power without TMS	1500		VA
Max input power with TMS	1800		VA
Weight			
Weight	80	83	kg

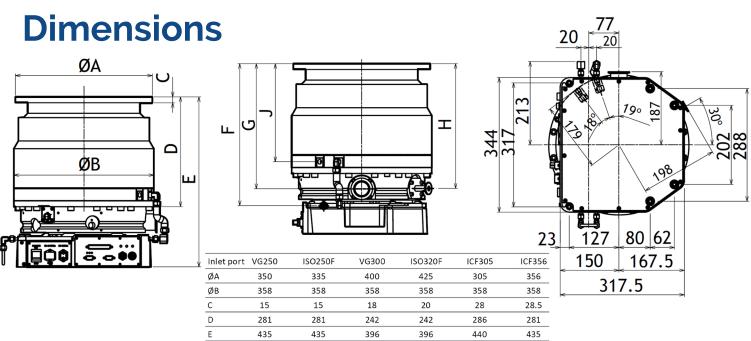
^{*1:} The maximum gas flow is applicable under conditions that ${\rm N_2}$ or Ar gas is pumped continuously with water cooling temperature under 25° C and the backing pump (10,000 l/min size) is used. It is changed on condition.

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Pumping Curves





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Features & Benefits

- compact design including fully integrated controller
- innovative, self-sensing magnetic bearing system
- digital 5-axis control
- vibration levels reduced by 50% compared to other turbos
- can be configured to run corrosive processes

Applications

 plasma etch · ECR etch · film deposition · sputtering · ion implantation source

